

Notice of References Cited		Application/Control No. 10/575,075	Applicant(s)/Patent Under Reexamination BILLAUD ET AL.	
		Examiner Bernarr E. Gregory	Art Unit 3662	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,063,386 A	11-1991	Bourdeau et al.	342/40
*	B	US-5,089,822 A	02-1992	Abaunza et al.	342/30
*	C	US-5,455,586 A	10-1995	Barbier et al.	342/37
*	D	US-5,486,829 A	01-1996	Potier et al.	342/40
*	E	US-5,528,244 A	06-1996	Schwab, Carl E.	342/37
*	F	US-5,835,059 A	11-1998	Nadel et al.	342/37
*	G	US-6,169,770 B1	01-2001	Henely, Steven J.	375/349
*	H	US-6,792,058 B1	09-2004	Hershey et al.	375/347
*	I	US-6,819,282 B1	11-2004	Galati et al.	342/37
*	J	US-2004/0233095 A1	11-2004	Galati et al.	342/37
*	K	US-7,391,359 B2	06-2008	Ootomo et al.	342/37
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	W. Stamper, "Understanding mode S technology"; "RF Design" magazine; December 2005 issue; pages 18-21; posted on the Internet at rfdesign.com.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.